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*O. Lawrence*  
#21002  
10.3.03

G22-0002  
RD27767-2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Radislav Alexandrich Potyrail	)	
Serial No.:	09/681,431	)	Group Art Unit: 1743
Filed:	April 4, 2001	)	
For:	SYSTEMS AND METHODS FOR RAPID EVALUATION OF CHEMICAL RESISTANCE OF MATERIALS	)	Examiner: Sines, Brian J

**RESPONSE**

**VIA FACSIMILE TO: (703) 872-9310**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

This is a response to the Office Action dated June 30, 2003. Applicants request reconsideration of the outstanding rejection in view of the following remarks.

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